## Amendments to Claims

This listing of claims will replace all prior versions and listing of claims in the application:

## Listing of Claims

- 1. (Previously presented) An integrated package comprising:
  - a first wafer having a first surface;
  - a second wafer having a first surface bonded at a first perimeter to the first surface of the first wafer; and
  - a recess formed in the first surface of the first wafer between the first perimeter and a second perimeter situated within the first perimeter for a window situated within the second perimeter.
- 2. (Previously presented) The package of claim 1, further comprising a first bump pattern in the first surface of the first wafer within the second perimeter.
- 3. (Previously presented) The package of claim 2, further comprising a second bump pattern on a second surface of the first wafer.
- 4. (Previously presented) The package of claim 3, further comprising a seal between the first and second wafers at the first perimeter.
  - 5. (Previously presented) The package of claim 4, 2 of 9

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wherein the seal comprises:

- a spacer material; and
- a layer of malleable material.
- 6. (Previously presented) The package of claim 5, wherein the seal further comprises a layer of bondable material.
- 7. (Previously presented) The package of claim 6, further comprising structural supports in the recess of the first wafer.
- 8. (Previously presented) The package of claim 7, further comprising at least one pumpout opening in the first wafer.
- 9. (Previously presented) The package of claim 8, wherein the first and second wafers comprise silicon.

## 10-25. (Canceled)

- 26. (Withdrawn) An integral package comprising:
- a first wafer comprising:
  - a seal along a first perimeter on a first surface of the first wafer; and
  - a trench in the first surface of the first wafer along a second perimeter within the first perimeter; and

- a second wafer having a first surface bonded to the first wafer along the seal.
- 27. (Withdrawn) The package of claim 26, wherein the first wafer further comprises an anti-reflective pattern on the first surface.
- 28. (Withdrawn) The package of claim 27, wherein the first wafer further comprises at least one vent hole and vent hole seal.
- 29. (Withdrawn) The package of claim 28, wherein the seal comprises a spacer material.
- 30. (Withdrawn) The package of claim 29, wherein the first wafer further comprises an anti-reflective pattern on a second surface.
  - 31. (Withdrawn) An integrated package comprising:
  - a first wafer having a first surface;
  - a second wafer having a first surface bonded at a first perimeter to the first surface of the first wafer;
  - a recess formed in the first surface of the first
     wafer in a second perimeter situated within the
     first perimeter;

structural supports in the recess of the first wafer; a first bump pattern in the first surface of the first

wafer within the second perimeter;

- a second bump pattern on a second surface of the first wafer; and
- a seal between the first and second wafers at the first perimeter; and

wherein the seal comprises:

- a spacer material;
- a layer of malleable material; and
- a layer of bondable material.
- 32. (Withdrawn) The package of claim 31, further comprising at least one pumpout opening in the first wafer.
- 33. (Withdrawn) The package of claim 32, wherein the first and second wafers comprise silicon.
  - 34. (Withdrawn) An integrated package comprising:
  - a first wafer having a first surface;
  - a second wafer having a first surface bonded at a first perimeter to the first surface of the first wafer;
  - a recess formed in the first surface of the first wafer in a second perimeter situated within the first perimeter; and
  - structural supports in the recess of the first wafer;
- 35. (Withdrawn) The package of claim 34, further comprising a seal between the first and second wafers at

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the first perimeter.

- 36. (Withdrawn) The package of claim 35, further comprising at least one pumpout opening in the first wafer.
- 37. (Withdrawn) The package of claim 36, further comprising a first bump pattern in the first surface of the first wafer within the second perimeter.
- 38. (Withdrawn) The package of claim 37, further comprising a second bump pattern on a second surface of the first wafer.
- 39. (Withdrawn) The package of claim 38, wherein the first and second wafers comprise silicon.
  - 40. (Withdrawn) An integrated package comprising:
  - a first wafer having a first surface;
  - a second wafer having a first surface bonded at a
     first perimeter to the first surface of the first
     wafer;
  - a recess formed in the first surface of the first wafer in a second perimeter situated within the first perimeter; and
  - a first bump pattern on a second surface of the first wafer.
  - 41. (Withdrawn) The package of claim 40, further

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comprising a seal between the first and second wafers at the first perimeter.

- 42. (Withdrawn) The package of claim 41, further comprising structural supports in the recess of the first wafer.
- 43. (Withdrawn) The package of claim 42, further comprising at least one pumpout opening in the first wafer.
- 44. (Withdrawn) The package of claim 43 a second bump pattern on a first surface of the first wafer.
- 45. (Withdrawn) The package of claim 44, wherein the first and second wafers comprise silicon.
  - 46. (Withdrawn) An integrated package comprising:
  - a first wafer having a first surface;
  - a second wafer having a first surface bonded at a first perimeter to the first surface of the first wafer:
  - a recess formed in the first surface of the first
    wafer between the first perimeter and a second
    perimeter situated within the first perimeter for
    a window situated within the second perimeter;
    and
  - at least one pumpout opening in the first wafer.

- 47. (Withdrawn) The package of claim 46, further comprising structural supports in the recess of the first wafer.
- 48. (Withdrawn) The package of claim 47, further comprising a first bump pattern in the first surface of the first wafer within the second perimeter.
- 49. (Withdrawn) The package of claim 48, further comprising a second bump pattern on a second surface of the first wafer.
- 50. (Withdrawn) The package of claim 49, further comprising a seal between the first and second wafers at the first perimeter.
- 51. (Withdrawn) The package of claim 50, wherein the first and second wafers comprise silicon.